

Poster Session

Dec.10 13:00-15:00

Yokohama Media & Communications Center 6th floor

Entry No	Presentation	Presenter_J(Family)	Presenter_J(First)	Presenter_E(Family)	Presenter_E(First)	Affiliation	Paper Title(J)	Paper Title(E)
10793	P-P10-001	北崎	訓	KITAZAKI	Satoshi	Faculty of Engineering Sciences, Kyushu University	DPPH法を用いた大気圧放電プラズマ処理収穫物の抗酸化活性計測	Measurement of Antioxidant Activity of Atmospheric Pressure Discharge Plasma Irradiation Crops using DPPH Method
10297	P-P10-002	小野	大帝	ONO	Reoto	Interdisciplinary Graduate School of Engineering Science, Kyushu University	酸素プラズマの導入による植物の抗酸化活性の制御	Control of Antioxidative Activity of Plants Induced by Oxygen Plasma
10357	P-P10-003	サリノント	タパナット	Sarinont	Thapanut	Graduate School and Faculty of Information Science and Electrical Engineering, Kyushu University		Effects of Water on Interaction between Plant Growth and Plasma
10544	P-P10-004	内田	詳平	UCHIDA	Shohei	Interdisciplinary Graduate school of Engineering Sciences, Kyushu University	植物種子へのプラズマ及びUV光照射による成長促進	Growth Enhancement of Plant by Plasma and UV light Irradiation to Seeds
10699	P-P10-005	白藤	立	SHIRAFUJI	Tatsuru	Dept. Physical Electronics and Informatics	水蒸気を含むAr DBDにおけるOH(A)生成へのH ₃ O ⁺ の解離再結合の寄与	On The Contribution of Dissociative Recombination of H ₃ O ⁺ to Produce OH(A) in DBD of Ar with Water Vapor
10587	P-P10-006	田中	昭匡	TANAKA	Akimasa	Interdisciplinary Graduate School of Engineering Science, Kyushu University	オゾンのUV光分解による活性酸素種を用いたチューブ内滅菌	Sterilization Treatment of Inner Surface of a Narrow Tube Using Synergy Effect of Ozone and UV light Irradiation
10538	P-P10-007	張	晗	CHOU	HAN	Graduate school of Engineering , Shizuoka University	RF励起NH ₃ プラズマを用いたグラフェン外包磁気ナノ微粒子のアミノ基表面修飾におけるNHラジカルの効果	Effect of NH Radicals on Amino Group Surface Modification onto Graphene-Encapsulated Magnetic Nanoparticles Using RF Excited NH ₃ Plasma
10703	P-P10-008	内田	儀一郎	UCHIDA	Giichiro	Joining and Welding Research Institute, Osaka University	生体医療応用のための大気圧誘電体バリア放電プラズマジェットの基礎特性(I)	Basic characteristics of atmospheric-pressure dielectric barrier discharge plasma jet for biomedical applications (I)
10701	P-P10-009	内田	儀一郎	UCHIDA	Giichiro	Joining and Welding Research Institute, Osaka University	生体医療応用のための大気圧誘電体バリア放電プラズマジェットの基礎特性(II)	Basic characteristics of atmospheric-pressure dielectric barrier discharge plasma jet for biomedical applications (II)
10704	P-P10-010	竹中	弘祐	TAKENAKA	Kosuke	Joining and Welding Research Institute, Osaka University	大気圧非平衡プラズマ照射後の生体分子の分子構造の変化	Variation of Molecular Structure of Bio-molecules after Atmospheric-pressure Plasma Irradiation
10564	P-P10-011	楊	樹斌	Yang	Shubin	Graduate School of Science and Technology, Shizuoka University/Institute of Plasma Physics, Chinese Academy of Science		Sorption Mechanism of Cesium Ions from Aqueous Solution by Chitosan-grafted Carbon Nanotubes and Bentonite by Plasma-induced Grafting Method

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10652	P-P10-012	柳生	義人	YAGYU	Yoshihito	Sasebo National College of Technology	大気圧バリア放電による柑橘類果皮に付着した緑かび病菌胞子(<i>Penicillium digitatum</i>)の不活化効果	Effect of atmospheric pressure dielectric barrier discharge irradiation to green mold spore, <i>Penicillium digitatum</i> , attached on citrus peel
20855	P-P10-013	スハリアディ	イピン	Suhariadi	Iping	Graduate School and Faculty of Information Science and Electrical Engineering Kyushu		Morphological Characterization of ZnO Thin Films Fabricated via Nitrogen Mediated Crystallization: Effects of Substrate Temperature

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10755	P-P11-001	大島	多美子	OHSHIMA	Tamiko	Sasebo National College of Technology	Bi粉とFe粉による混合粉体のパルスレーザ堆積	Pulsed Laser Deposition of Mixed Powder Target Containing Bismuth Powder and Iron Powder
10527	P-P11-002	高野	貴文	TAKANO	Takafumi	Graduate School of Engineering, Shizuoka University	沿面放電による常温大気圧下でのSnO ₂ 膜の作成	SnO ₂ thin films prepared by surface discharge technique at room temperature under atmospheric pressure
10706	P-P11-003	竹中	弘祐	TAKENAKA	Kosuke	Joining and Welding Research Institute, Osaka University	プラズマ支援ミストCVDで堆積した酸化亜鉛薄膜の表面構造分析	Surface Structure Analysis of Zinc Oxide Thin films Deposited by Plasma-Assisted Mist Chemical Vapor Deposition
10690	P-P11-004	市村	進	ICHIMURA	Susumu	Okayama University/Chubu University	マイクロ波表面波プラズマCVDによるグラフェンの合成とその評価	Synthesis and Evaluation of Graphene by Microwave Surface Wave Plasma CVD
10660	P-P11-005	篠原	正典	SHINOHARA	Masanori	Nagasaki University	Monitoring of plasma process with infrared absorption spectroscopy in multiple internal reflection	Monitoring of plasma process with infrared absorption spectroscopy in multiple internal reflection
10638	P-P11-006	秋山	卓也	AKIYAMA	Takuya	Department of Materials Engineering, The university of Tokyo	メゾプラズマCVDによるSiC高速堆積	Fas rate deposition of thick SiC films by mesoplasma CVD
10657	P-P11-007	ティーマン	ムサブ	TIMAN	Musab	Nagasaki University	液中プラズマ生成による炭素関連パーティクルの生成	Carbon-related particle formation with plasma generated in liquid phase
10420	P-P11-008	林	祐衣	HAYASHI	Yui	Graduate School of engineering, Nagoya University	気液界面におけるパルス放電プラズマによる酢酸アンモニウムからのアミノ酸合成	Amino Acid Formation from Ammonium Acetate by Pulsed Discharge Plasma at Pressurized Gas-Liquid Interface
10479	P-P11-009	都甲	将	TOKO	Susumu	Kyushu University	マルチホール放電電圧振幅変調による放電で形成されるクラスター量への効果	Effects of Amplitude Modulation of Discharge Voltage of Multi-Hollow Silane Discharges on Amount of Clusters Formed in the Discharges
10100	P-P11-010	荻野	明久	OGINO	Akihisa	Shizuoka University	光支援熱電子発電のためのセシウム被覆半導体表面の電子放出特性	Electron Emission Property of Cesiated Semiconductor Surface for Photon Enhanced Thermionic Energy Converter
10592	P-P11-011	説田	貴仁	SETSUDA	Takahito	Shizuoka University	低温で動作する光支援熱電子発電器の出力特性における空間電荷の効果	Effect of Space Charge on Output Characteristics of Thermionic Energy Converter Using Photon Enhanced Thermionic Emission for Low-temperature Operation

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10595	P-P11-012	川崎	仁晴	KAWASAKI	Hiroharu	Sasebo National College of Technology	紫外線を併用したグライディングアーク放電の特性	Characteristic of the gliding arc discharge for plasma process with ultra-violet light source
10593	P-P11-013	板良敷	朝将	ITARASHIKI	Tomomasa	Interdisciplinary Graduate school of Engineering Sciences Kyushu University	トーチ型マイクロ波プラズマを用いた芽胞の不活性化の特性	Inactivation Characteristics of Bacillus Spore Using Microwave Multi-type Torch Plasma